



520.39649CX3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MASUDA et al

Serial No.: 10/810,598

Filed: March 29, 2004

For: Plasma Processing System And A Sample Processing Method

Art Unit: 1763

Examiner: R. Kackar

AMENDMENT

Mail Stop: Box AF Amendment (Fee)

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

April 11, 2006

Sir:

The following amendments and remarks are respectfully submitted in connection with the accompanying RCE of above-identified application, and in response to the Office Action dated January 11, 2006. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.